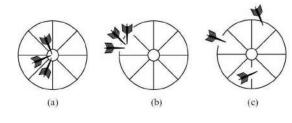
3 Basic Phenomenon in Effect in Sensor Operation

Sensors Prof. Dr. M. Zahurul Haq
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Bangladesh University of Engineering & Technology ME 361: Instrumentation & Measurement Image: Descent Contemport Sensors

Measurement Specification

- Resolution refers to the smallest change in the measured variable that can be detected by the sensor.
- Accuracy refers to the difference between the actual value and the measured value.
- Repeatability refers to the average error between consecutive measurements of the same value.



Sensors

(a) Accurate

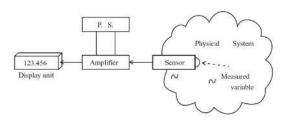
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(b) Repeatable but not accurate

(c) Not repeatable not accurate

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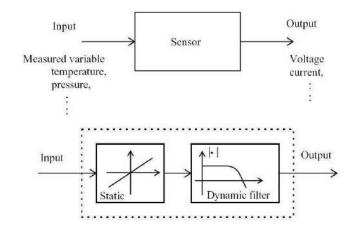
- Change (or the absolute value) in the measured physical variable (i.e. pressure, temperature, displacement) is translated into change in sensor property (resistance, capacitance, magnetic coupling). This is called the *transduction*.
- 2 Change in the sensor property is translated into low-power-level electrical signal in the form of electrical voltage or current.
- 3 Low-level-power sensor signal is conditioned and transmitted for processing i.e. display or for use in control systems.

Sensors

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Input-Output Model of Sensors



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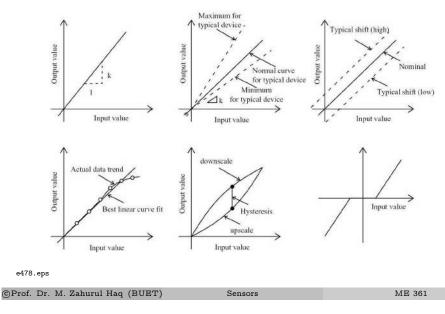
Dynamic response of a sensor can be represented by its frequency response or by its bandwidth specification

Sensors

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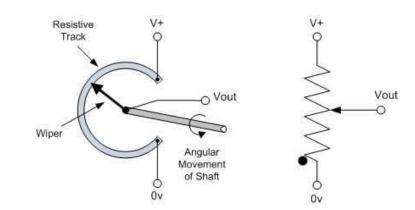
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Non-linear Variation of Input-Output Relationship



Resistive Sensors

Resistive Sensors



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Change is measured physical variable (e.g. pressure, load, torque, position etc.) results in resistance of resistive sensors.

Sensors

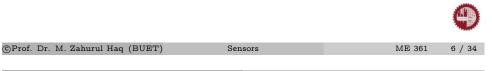
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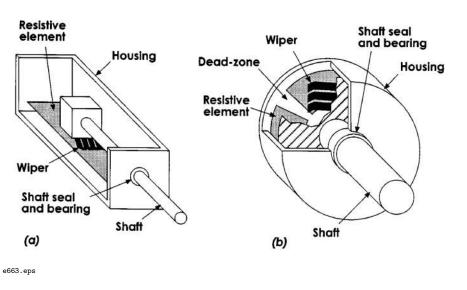
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Sensor Calibration

- Calibration afford the opportunity <u>to check</u> the instrument against a known standard and subsequently <u>to reduce errors</u> in accuracy.
- Calibration process involves adjustment to compensate for the variation in:
 - Gain
 - Offset
 - Saturation
 - Hysteresis
 - Dead band
 - Drift in time



Resistive Sensors



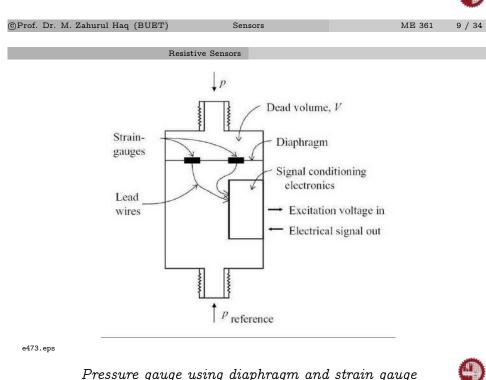
Typical linear and rotary potentiometers

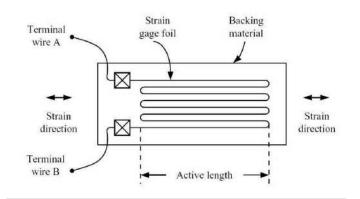
Sensors

Resistive Sensors

Characteristics of Resistive Sensors

- Very simple device, also known as potentiometer or <u>rheostat</u>.
- Contains a resistance element that is contacted by a movable contact (or slide or wiper) to measure linear or angular displacement.
- Available commercially in many sizes, designs, ranges and prices.
- May be used to measure pressure, torque or force as it is possible to convert these to displacement by mechanical means.
- Electrical efficiency is very high and may provide sufficient output to permit control without any amplification.
- May be ac- or dc- excited.
- Because of friction life is limited and may generate noise.





 $\frac{\Delta R}{R} = G \frac{\Delta L}{L} = \epsilon G$

Sensors

e468.eps

In strain gauge,

 $V_{out} = k_1 \frac{\Delta R}{R} = k_2 G$

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Resistive Sensors

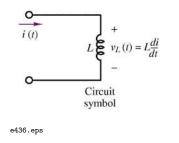


Various load cells using strain gauges for force and torque measurements

Sensors

Sensors

$$v_L(t)=-Lrac{di}{dt}=-rac{d\lambda}{dt}=-Nrac{d\phi}{dt}$$



- Flux linkage, λ = Nφ = Li: amount of flux linking the N turns of coils, φ is the flux passing through the coil.
- Self inductance, L measures the voltage induced by the magnetic field generated by a current flowing in the circuit.

Electromagnetic induction is the creating of an emf in a conductor which is moving in a magnetic field, or is placed in a changing magnetic field. *Faraday's Law of Induction* states that an emf is induced on a circuit due to changing magnetic flux and the induced voltage opposes the change in the magnetic flux (*Lenz's Law*).

Inductive Sensors

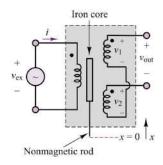
- In inductive transducers, a core moves linearly inside a transformer consisting of a center primary coil & two secondary coils.
- The secondary coils have equal number of turns & are connected in series opposing so that the emfs induced in the coils oppose each other. When core is centred voltage output is zero.
- When the core is moved off center, net voltage output varies linearly with core's position. When operating within linear range, it is known as *Linear Variable Differential Transformer* (LVDT).

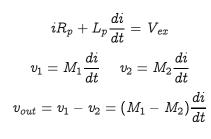
Applications:

Used to measure position, pressure, liquid level, vibration, acceleration & shock. May be configured to many kinds of specialized applications. The list includes standard, long-travel & miniature types, rotary variable differential transformers (RVDTs), high-temperature & cryogenic types, LVDTs designed for hostile environments, hermetically sealed, high-pressure, large-bore & nuclear-rated units.

Sensors

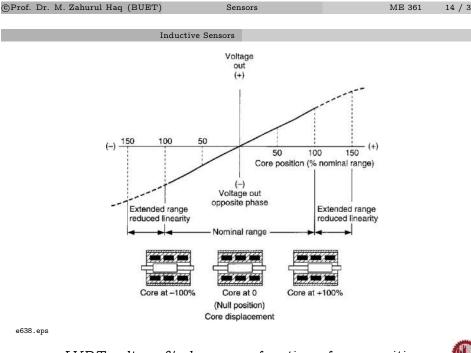
LVDT: Linear Variable Differential Transformer





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- $M_1 \& M_2$: mutual inductances
- Ferromagnetic core determines the magnetic coupling between primary and secondary coils.
- If core $\uparrow \to \to$ more coupling between with top coil $\to v_{out} > 0$. At null position: $M_1 = M_2 \mapsto v_{out} = 0$. In LVDT, $M_1 M_2$ is linearly related to the core displacement.



LVDT voltage & phase as a function of core position

Sensors

LVDT Characteristics

Input

 type range impedance char. sensitivity 	: Linear displacement. : $\pm 0.1 - \pm 75$ mm. : Require $10^{-3} - 3 \cdot 10^{-3}$ N force. : 0.5% of total input range.
Output	
⊙ type	: Voltage \propto input displacement.
\odot range	: 16 – 160 mV/mm; $f \uparrow \rightarrow$ output \uparrow .
\bigcirc impedance char.	: Mainly resistive; as low as 20 Ω .
Frequency response	: 50 Hz to 20 kHz. Applied frequency must
	be 10 times desired response.
Temperature effects	: Small influence; use thermistor to reduce.
Error	: Deviation from linearity is about 0.5%;
	generally accurate to 1.0%.

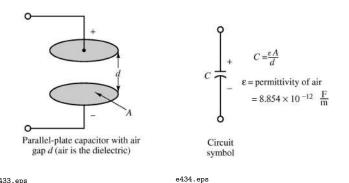
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Capacitive Sensors

Capacitive Sensors



Sensors

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- Physical variable to be measured can be used to change in the capacitance by changing: (1) d, (2) A or (3) ε.
- Capacitance may be measured with bridge circuits. High-output impedance requires careful construction of output circuitry.

Sensors

• Output impedance, Z of a capacitor is given by: $\Longrightarrow Z = \frac{1}{2\pi fC}$

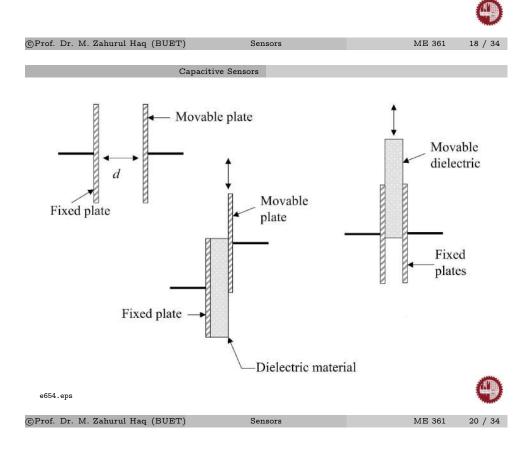
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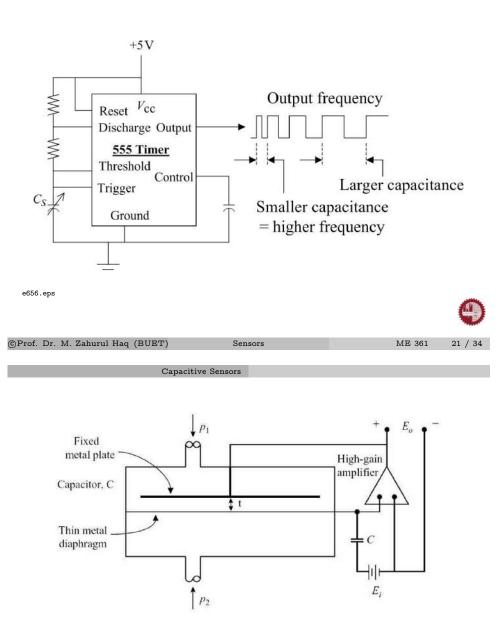
Advantages:

- Good accuracy, sensitivity and linearity
- Frictionless operation
- Ruggedness
- Physical, electrical and environmental isolation
- Cross-axis rejection
- Infinite resolution.

Disadvantages:

- Moving mass (inertia)
- Susceptible to stray ac magnetic fields
- Physical size
- Circuit requirements for full rated accuracy.





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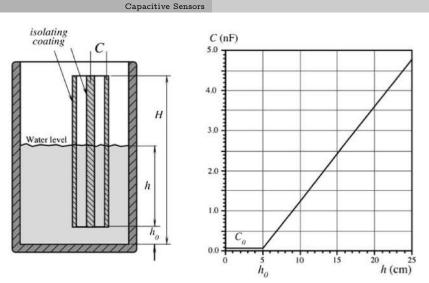
$$\Delta P \rightarrow t \rightarrow C \rightarrow E_o$$

Sensors

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Capacitive Sensors

Capacitive Transducer Characteristics: Input : Displacement, area or change in ϵ . (\cdot) type range : Very broad; from $1\mu m$ to several meters. \odot impedance char. : Require very small force, few dynes. (\cdot) sensitivitv : Highly variable; can obtain 400 pF/mm. (\cdot) Output type : Capacitance. (\cdot) : Usually $10^{-3} - 10^3$ pF. range \odot : Usually $10^3 - 10^7 \Omega$. impedance char. (\cdot) : Depends on construction; up to 50 kHz. Frequency response Temperature effects : Not strong if design allows for effects. **Applications:** \bigcirc Pressure & force measurement \bigcirc Level measurements & switches ○ Displacement measurement ○ Moisture & humidity measurement ○ Proximity detectors ○ Tachometers ○ Capacitive microphones considered capable of the highest performance).



Sensors

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Capacitive water level sensor & typical capacitance as a function of water level

Sensors

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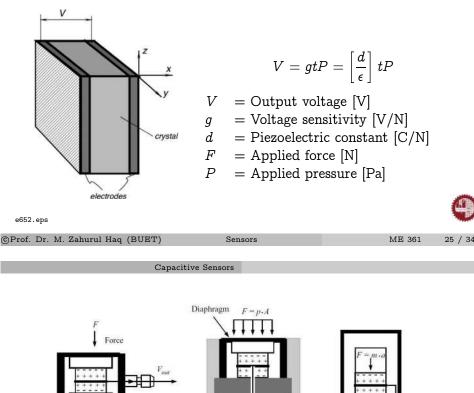
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Capacitive Sensors

Piezoelectric transducers

Piezoelectric transducers involve a class of materials which, when mechanically deformed, produce an electric charge. The effect is reversible and applied usefully in both directions.



Base

Piezoelectric force sensor

Piezoelectric pressure sensor

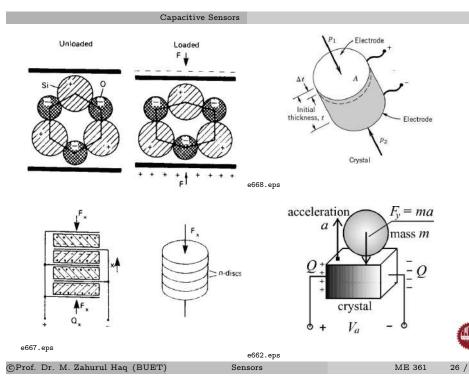
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Applications: <u>Used to measure</u>: () Surface roughness () Strain \bigcirc Force & torque \bigcirc Pressure \bigcirc Motion \bigcirc Sound & noise. Also used in: () Ultrasound NDT equipments () Sonar system () Ultrasound flow-meters () Small vibration shakers () Pumps for ink-jet printers \bigcirc Micro-motion actuators.

Sensors

Object whose acceleration is measured

Piezoelectric acceleration sensor



Capacitive Sensors

Piezoelectric materials: natural (quartz, rochelle salt) & synthetic crystals (lithium sulphate, ammonium dihydrogen phosphate), polarized ferroelectric ceramics (barium titanate & some polymer films).

Transducer Characteristics:

Input

 (\cdot)

 (\cdot)

 (\cdot)

 (\cdot)

 (\cdot)

 (\cdot)

- type
 - : Force or stress.
 - : Varies widely with crystal material.
- impedance char. : Input force required are relatively large.
- sensitivity (\cdot)

range

 \rightarrow Quartz \sim 0.05 Vm/N.

: Varies with material:

- \rightarrow Rochelle salt \sim 0.015 Vm/N.
- \rightarrow Barium titanate ~ 0.007 Vm/N.

: Wide, depends on crystal size & material.

Output

- type range : High, of the order of $10^3 M \Omega$.
- impedance char. Frequency response
 - : 20- 20 kHz, no steady-state response.

Sensors

: Wide variation with temperature.

: Voltage proportional to input.

Temperature effects ©Prof. Dr. M. Zahurul Haq (BUET)

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Photoemissive & Photoelectric Transducers

- Photoemissive transducers consist of a cathode-anode combination enclosed in a glass or quartz envelope, which is either evacuated or filled with an inert gas.
- In the proper circuit (usually a d.c. source from 100 200 V), light impingement on the cathode frees electrons to flow, thereby providing a small current given by: \Longrightarrow $I = S\Phi$

$$I = photoelectric currents$$

= illumination on cathode Φ

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- S= sensitivity.
- Photoelectric-tube response in different wavelength depends on:
 - 1) Photo-emissivity of the cathode material $(0.2 0.8 \mu m)$.
 - 2 Transmissivity of the glass-tube envelope.
 - Most glasses do not transmit light below about $0.4 \mu m.$
 - Quartz transmits down to $0.2\mu m$. Sensors

Optical Sensors

Photovoltaic Cells

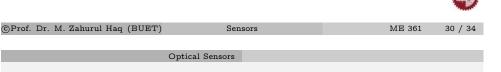
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- Photovoltaic-cell (solar cell) consists of a metal base plate, a semiconductor material, and a thin transparent metallic layer. When light strikes the barrier between the transparent metal layer and the semiconductor material, a voltage is generated.
 - Si cells cover the visible & near-infra-red spectrum, intensities between $10^{-3} - 10^3 mW/cm^2$.
 - Se cells accepts a spectrum of near-infra-red to ultraviolet, intensities between $10^{-1} - 10^2 mW/cm^2$.
- The output of the device is strongly dependent on the load resistance R_{\cdot}
- The logarithmic behaviour of the cell is a decided advantage in such applications because of its sensitivity over a broad range of light intensities.
- Most widely used applications of the PVC include the light exposer meter in photographic work and solar radiation measurement. Sensors

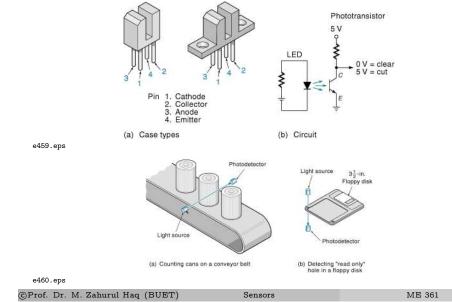


Optical Sensors Photo-conductive/Photo-resistive Transducers

- Photo-conductive cells are elements whose conductivity is a function of the incident electromagnetic radiation. Commercially important materials are cadmium sulphide, germanium, and silicon.
- The essential elements of a photo-conductive cell are the ceramic substrate, a layer of photo-conductive material, metallic electrodes and a moisture-resistant enclosure.
- Lead-sulphide cell is widely used for detection of thermal radiation in the wavelength band of $1 - 3\mu m$. By cooling the detector higher wavelength (= $4 - 5\mu m$) can be achieved.
- The spectral response of CdS cell closely matches that of human eye, and the cell is often used in applications where human vision is a factor.



Phototransistor Sensors



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